



**ELECTRONIC COPY**

LG788611665  
Report verification at igi.org



March 31, 2026  
IGI Report Number **LG788611665**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **11.19 X 7.84 X 5.56 MM**  
**GRADING RESULTS**  
Carat Weight **5.04 CARATS**  
Color Grade **D**  
Clarity Grade **VVS 1**

March 31, 2026  
IGI Report Number **LG788611665**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **11.19 X 7.84 X 5.56 MM**

**GRADING RESULTS**

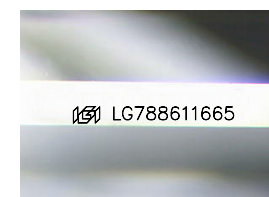
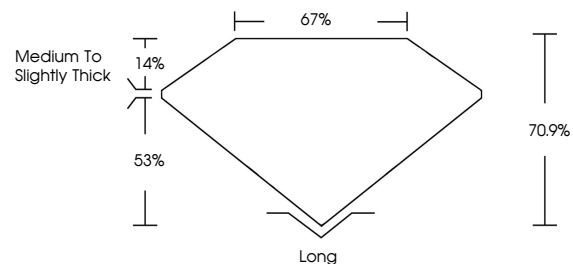
Carat Weight **5.04 CARATS**  
Color Grade **D**  
Clarity Grade **VVS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG788611665**

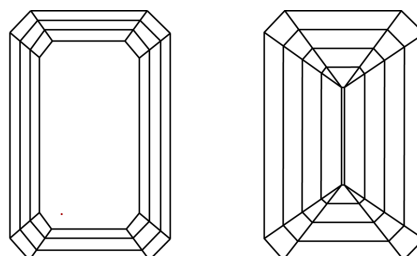
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

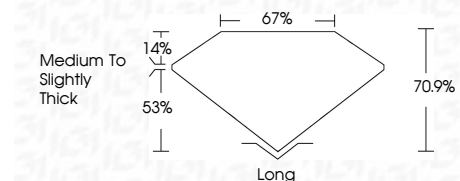
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG788611665**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



March 31, 2026  
IGI Report No **LG788611665**  
**EMERALD CUT**  
**5.04 CARATS**  
Carat Weight **D**  
Color Grade **VVS 1**  
Clarity Grade **70.9%**  
Depth **67%**  
Table **Medium to Slightly Thick**  
Girdle **Long**  
Culet **EXCELLENT**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG788611665**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa